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JUL 03 2007

Confirmation No. 6408IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Meunier-Beillard *et al.* Examiner: Khiem Nguyen  
Serial No.: 10/550,853 Group Art Unit: 2823  
Filed: September 22, 2005 Docket No.: NL030357 US1  
Title: METHOD OF EPITAXIAL DEPOSITION OF AN N-DOPED SILICON  
LAYER

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence and the papers, as described hereinabove, are being transmitted via facsimile-Formal Entry, to the attention of the Examiner at Commissioner for Patents, MAIL STOP AMENDMENT, P.O. Box 1450, Alexandria, VA 22313-1450, on July 3, 2007.

By: Kelly Davis

Kelly Davis

Facsimile No.: 571 273-8300

OFFICE ACTION RESPONSE

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Customer No.  
**65913**

Dear Sir:

In response to the Office Action dated April 3, 2007, please reconsider the application in view of the following amendments and remarks.

A complete listing of the claims, to include any amendments presented therein, begins on page 2 of this paper.

Remarks/Arguments follow on page 5.

Authorization is provided to charge/credit Deposit Account 50-0996  
(NXPS.265PA) any requisite fees/overages to enter this paper.